

Docket No.: H6810.0021/P021

(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Akira Sekine et al.

Application No.: 09/858,477

Confirmation No.: 2982

Filed: May 17, 2001

Art Unit: 1743

For: METHOD AND SYSTEM FOR

Examiner: Y. G. Gakh

COMPREHENSIVE MANAGEMENT OF

CHEMICAL MATERIALS

INFORMATION DISCLOSURE STATEMENT (IDS)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Pursuant to 37 C.F.R. §§ 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is directed to the references listed on the attached PTO/SB/08. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

I hereby certify that each item of information contained in this Information

Disclosure Statement was first cited in any communication from a foreign patent office in a

counterpart foreign application not more than three months prior to the filing of this

Information Disclosure Statement.

The reference on the attached PTO/SB/08 has been cited in an European 12/07/2004 ASINGLET 00000001 041073 09858477 Examination Report in conjunction with the prosecution of a related patent application. A copy of the Report is attached.

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